

Zachai *et al.* Reply: In a recent Letter¹ we reported on the first observation of superlattice-related photoluminescence (PL) in the energy range around 0.8 eV from strained-layer, short-period Si/Ge superlattices (SLS's) grown on (001) Si substrates. The PL results were related to the fundamental zone-folded direct band gap predicted in Si/Ge SLS's with a period of ten monolayers (ML).² The strongest luminescence was observed at about 0.84 eV from a strain-symmetrized Si₆Ge₄ SLS [(6 ML Si)/(4 ML Ge)].

The authors of the preceding Comment³ calculated the band structure of the strain-symmetrized Si₆Ge₄ SLS by means of a local-density-functional method (LDA) combined with a semiempirical determination of excitation energies. They believe that the observed PL cannot be assigned to the quasidirect band gap of the SLS. Their arguments mainly rely on the discrepancy of about 250 meV between the estimated LDA superlattice band gap (1.08 eV) and the experimental transition energy (0.84 eV). They suggest that the SLS luminescence originates in dislocation luminescence (*D*₂ line), which was observed at about the same energy in a liquid-phase-epitaxially (LPE) grown Si_{0.6}Ge_{0.4} alloy layer.⁴

We do observe similar luminescence features from a corresponding Si_{0.6}Ge_{0.4} alloy-layer reference sample as in Ref. 4. This alloy reference sample was grown immediately after the preparation of the strain-symmetrized Si₆Ge₄ SLS in the same molecular-beam-epitaxy chamber on nominally the same buffer layer. The density of dislocations is expected to be of the same order of magnitude in both samples. In Fig. 1, we show both the SLS luminescence (lower part) and alloy-layer luminescence (upper part) for direct comparison. The signal at about 1.1 eV (Si-Sub) is the well-known phonon-assisted excitonic luminescence from the Si substrate. The energetic positions of the PL signals measured by Weber and Alonso⁴ in the LPE-grown alloy layer are indicated by arrows. They attributed their alloy luminescence signals to dislocation-related transitions (*D*₁ to *D*₄, below 0.95 eV) and phonon-assisted bound-exciton transitions (BE, 0.96 eV). The much stronger intensity (factor of 10–20, see scaling factor in the upper part) and the completely different spectral behavior of the SLS luminescence strongly indicate that the superlattice luminescence cannot be assigned to alloy-related dislocation transitions.

The LDA calculations predict the fundamental quasidirect band gap at 1.08 eV. However, no superlattice-related PL is observed near this energy. Since excitonic phonon-assisted interband transitions are observed even in the indirect Si-Ge alloy layer (BE in the upper part of Fig. 1), one expects to measure interband transitions also in the superlattice. This is in disagreement with the theoretical interband energy calculated by the authors of the Comment. Furthermore, the observed redshift of the SLS luminescence with increasing strain in the Si layers and the absence of strong luminescence in a 20-ML period SLS¹ agree well with the predictions of other

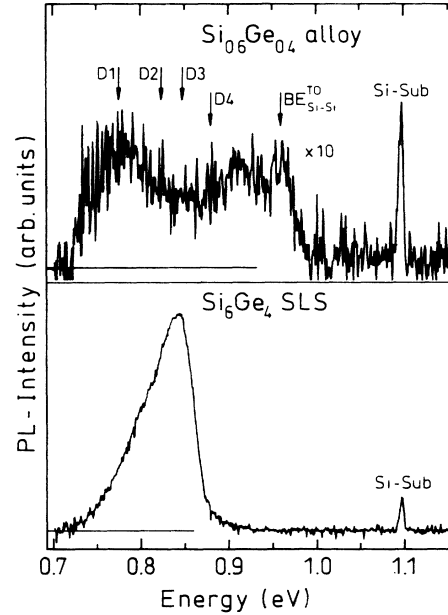


FIG. 1. Low-temperature ($T \approx 5$ K) photoluminescence spectra from a strain-symmetrized Si₆Ge₄ superlattice ($\epsilon_{\parallel}^{\text{Si}} \approx 1.4\%$, $\epsilon_{\parallel}^{\text{Ge}} \approx -2.7\%$) (lower part) and from the corresponding Si_{0.6}Ge_{0.4} alloy-layer reference sample (upper part) measured under the same experimental conditions. The arrows mark the energetic positions of the luminescence features observed from a LPE-grown Si_{0.6}Ge_{0.4} alloy layer (Ref. 4).

theoretical groups.² Consequently, we still believe that our experimental results support the prediction of a fundamental quasidirect band gap with enhanced dipole-allowed transition rate.

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¹R. Zachai, K. Eberl, G. Abstreiter, E. Kasper, and H. Kibbel, *Phys. Rev. Lett.* **64**, 1055 (1990).

²See, for example, S. Satpathy, R. M. Martin, and C. G. van de Walle, *Phys. Rev. B* **38**, 13237 (1988).

³U. Schmid, N. E. Christensen, and M. Cardona, preceding Comment, *Phys. Rev. Lett.* **65**, 2610 (1990).

⁴J. Weber and M. I. Alonso, in *Proceedings of the International Conference on Science and Technology of Defect Control in Semiconductors*, edited by K. Sumino (Elsevier, New York, to be published).